Docket No.: 060188-0578 **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Shinichi IMAI, et al.

Confirmation Number: 4939

Application No.: 10/619,191

Group Art Unit: 2125

Filed: July 15, 2003

Examiner: Maria N. Von Buhr

For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION

**APPARATUS** 

## PETITION FOR EXTENSION OF TIME

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated June 21, 2006, now due to expire September 21, 2006, be extended for one month and set to expire on October 21, 2006.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

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Registration No. 36,139/20/2026 HAHHED1 00000078 500417

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Please recognize our Customer No. 20277

as our correspondence address.

